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AP3 Rec'd PCT/PTO 31 MAY 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

NAKAYAMA ET AL.

Atty. Ref.: 925-342

Serial No. Unknown

TC/A.U.: Unknown

Filed: May 31, 2006

Examiner: Unknown

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREFOR

* * * * *

May 31, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached International Search Report and form PTO/SB/08a.

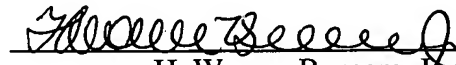
This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO/SB/08a and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By:



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SERIAL NO.

Unknown

NAKAYAMA ET AL.

FILING DATE

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May 31, 2006

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							TRANSLATION	
DOCUMENT			DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
		2001/018872	3/2001	WO				
		2000-001398	1/2000	JP				
		03-171772	7/1991	JP				
		2002-514355	5/2002	JP				
		11-060390	3/1999	JP				

[illegible]

Date Considered

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